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(Rev. 8-83)

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Patent and Trademark Office

Attorney Docket No. 0819-374

Serial No. Not Yet Assigned

# INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Takeshi TAKAGI et al.

Filing Date: September 1, 2000

Group: Not Yet Assigned

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
	5,246,316	6/20/95	Mohammad			

## FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation Yes No
WS	6-66519	8/24/94	Japan			Abstract
	4-273491	9/29/92	Japan			Abstract
	6-204457	7/22/94	Japan			Abstract
	5-275717	10/22/93	Japan			Abstract
	5-259440	10/8/93	Japan			Abstract
	6-260493	9/16/94	Japan			Abstract
	2 288 691	10/25/95	United Kingdom			Full
	2 260 858	4/28/93	United Kingdom			Full
✓	09-283533	10/31/97	Japan			Abstract

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

WSL	J.S. Yuan, "Switch-Off Transient Analysis for Heterojunction Bipolar Transistors in Saturation", Solid-State Electronics, Vol. 36, No. 9, pp. 1261-1266, 1993.
	M. Ugajin et al., "The Base-Collector Heterojunction Effect in SiGe-Base bipolar Transistors", Solid-State Electronics, Vol. 34, No. 6, pp. 593-598, 1991.
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	S.P. Wainwright et al., "A Stored Charge Model for Integrated Injection Logic (I <sup>2</sup> L) Structures Using Si/SiGe Material", Proc. of European Solid State Device Research Conference, pp. 649-652, 1996.
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Date Considered

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449 (Rev. 8-83)		U.S. Department of Commerce Patent and Trademark Office		Atty Docket 0819-0374		Serial No. 09/659,484	
<b>INFORMATION DISCLOSURE STATEMENT</b>				Applicants: Takeshi TAKAGI et al.			
				Filing Date: September 11, 2000		Group Art Unit: 2814	
<b>FOREIGN PATENT DOCUMENTS</b>							
Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	N
WSL	01-231371	09/14/1989	JP			Part. Eng. & Abst.	
	05-121677	05/18/1993	JP			Eng Abst	
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V	64-009656	01/12/1989	JP			Part. Eng. & Abst.	
<b>OTHER DOCUMENT</b> (Including Author, Title, Date, Pertinent Pages, Etc.)							
Examiner Initial							
WSL	Notice of Reasons of Rejection, Patent Application No. 10-154689 Mailing Date: October 2, 2001, Mailing No. 2033500001, with English Translation						
WSL	Notice of Reasons of Rejection, Patent Application No. 10-154700 Mailing Date: October 2, 2001, Mailing No. 2033500007, with English Translation						
Examiner				Date Considered <u>9/30/02</u>			
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## FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
WSV	803-198344	08/29/1991	JP			Part Eng	

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WSV	Notice of Reasons of Rejection, Patent Application No. 10-154689 Mailing Date: June 4, 2002, Docket No. 2033500001, with Mailing No. 172502

Examiner

Date Considered

9/30/02

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